

Application No.: 09/837,902

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Docket No.: 495152000110

REMARKS/ARGUMENTS

In the Office Action dated July 29, 2004, claims 110 and 116-119 were rejected. By this Amendment, claim 110 has been amended. Claims 116, 122, and 127 have been amended to correct minor typographical errors. New claims 139-159 have been added.


The Examiner rejected claims 110 and 116-119 under 35 U.S.C. 102(b) as being anticipated by U.S. Patent 5,326,455 (the Kubo reference). Claim 110 has been amended to recite that the substrate is a "wafer used in integrated circuit fabrication", rotated "about a center-point", and the film is plated at a second portion "at a different radial location from the first portion." Applicants assert that the Kubo reference does not disclose these limitations. Thus, Applicants assert that claims 110 and 116-119, which depend from claim 110, are allowable over the Kubo reference.

New independent claims 139 and 157 recite, "rotating the wafer about a center-point", "plating the film...at a first radial location on the wafer", and "plating the film...at a second radial location different from the first portion." Applicants assert that the Kubo reference does not disclose these limitations. Thus, Applicants assert that new claims 139-159 are allowable.

In the unlikely event that the transmittal form is separated from this document and/or the Patent Office determines that an extension and/or other relief is required, Applicants petition for any required relief including extensions of time and authorize the Commissioner to charge the cost of such petitions and/or other fees due in connection with the filing of this document to Deposit Account No. 03-1952 referencing 495152000110. The Commissioner is not authorized to charge the cost of the issue fee to the Deposit Account.

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Respectfully submitted,

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